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AUG 31 2004

**DIRECTOR'S OFFICE
TECHNOLOGY CENTER 3600**

In re Application of
Richard N. Savage et al.
Application No. 09/767,659
Filed: January 22, 2001

**DECISION ON PETITION
TO WITHDRAW THE
HOLDING OF ABANDONMENT**

For: **SEMICONDUCTOR WAFER PROCESSING
SYSTEM WITH VERTICALLY-STACKED PROCESS
CHAMBERS AND SINGLE-AXIS DUAL-WAFER TRANSFER SYSTEM**

This is in reply to the renewed petition to withdraw the holding of abandonment under 37 CFR 1.181, filed in the United States Patent and Trademark Office, on June 14, 2004.

The petition is **GRANTED** in view of the following evidence of timely filing :

- ☐ Postcard receipt being dated _____.
- ☐ USPTO return facsimile receipt dated _____ which identifies the application by serial number and the type of Response that was filed on that date.
- ☒ Certificate of Mailing/Transmission signed on April 29, 2003 and supported by a statement under 37 C.F.R. 1.8(b)(3).
- ☐ Hand Delivery Receipt of the specific documents submitted dated _____.
- ☐ Certificate of Transmission of CPA under 37 C.F.R. 1.6 filed on _____.
- ☐ Express Mail Receipt under 37 C.F.R. 1.10 dated _____.

This application is being forwarded to the Supervisory Legal Instruments Examiner for entry of the response filed with the petition, then to the examiner for prompt action on the response.

SNM/vdb: 8/26/04

**STEVEN N. MEYERS
SPECIAL PROGRAM EXAMINER
TECHNOLOGY CENTER 3600**